

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the application of: DiCarlo *et al.*  
Application No.: 11/750,142  
Filed: 12/31/2003  
For: Method for Removal of Pattern Resist  
Over Patterned Metal Having an  
Underlying Spacer Layer

Docket: TI-36187  
Examiner: Vinh, Lan  
Art Unit: 1765  
Conf. No.: 7928

**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION	
I hereby certify that the above correspondence is being filed electronically with the U.S. Patent and Trademark Office on the date indicated below.	
<u>/Sue Short/</u>	<u>12/21/07</u>
Sue Short	Date

Dear Sir:

In response to the Notice of Allowance and Fee(s) Due mailed October 4, 2007,  
Applicants submit the following comments:

**REMARKS**

The Applicants agree with the Examiner's conclusions of patentability, without necessarily agreeing with or acquiescing in the Examiner's reasoning or comments. The Applicants submit that the claims of the above-identified application are allowable because the prior art fails to anticipate or render obvious the invention as claimed.

Respectfully submitted,

/Charles A. Brill/  
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